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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
09/955,076	09/19/2001	Eiji Sakagami	214019US2	9771

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EXAMINER

WEISS, HOWARD

ART UNIT	PAPER NUMBER
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2814

DATE MAILED: 06/06/2002

Please find below and/or attached an Office communication concerning this application or proceeding.

# Office Action Summary

Application No.

09/955,076

Applicant(s)

SAKAGAMI, EIJI

Examiner

Howard Weiss

Art Unit

2814

-- The MAILING DATE of this communication appears on the cover sheet with the correspondence address --

## Period for Reply

A SHORTENED STATUTORY PERIOD FOR REPLY IS SET TO EXPIRE 3 MONTH(S) FROM THE MAILING DATE OF THIS COMMUNICATION.

- Extensions of time may be available under the provisions of 37 CFR 1.136(a). In no event, however, may a reply be timely filed after SIX (6) MONTHS from the mailing date of this communication.
- If the period for reply specified above is less than thirty (30) days, a reply within the statutory minimum of thirty (30) days will be considered timely.
- If NO period for reply is specified above, the maximum statutory period will apply and will expire SIX (6) MONTHS from the mailing date of this communication.
- Failure to reply within the set or extended period for reply will, by statute, cause the application to become ABANDONED (35 U.S.C. § 133).
- Any reply received by the Office later than three months after the mailing date of this communication, even if timely filed, may reduce any earned patent term adjustment. See 37 CFR 1.704(b).

## Status

- 1) ☐ Responsive to communication(s) filed on 15 May 2002.
- 2a) ☐ This action is FINAL. 2b) ☒ This action is non-final.
- 3) ☐ Since this application is in condition for allowance except for formal matters, prosecution as to the merits is closed in accordance with the practice under *Ex parte Quayle*, 1935 C.D. 11, 453 O.G. 213.

## Disposition of Claims

- 4) ☐ Claim(s) 1-21 ~~is~~ are pending in the application.
- 4a) Of the above claim(s) 7-21 ~~is~~ are withdrawn from consideration.
- 5) ☐ Claim(s) \_\_\_\_\_ is/are allowed.
- 6) ☐ Claim(s) 1-6 ~~is~~ are rejected.
- 7) ☐ Claim(s) \_\_\_\_\_ is/are objected to.
- 8) ☐ Claim(s) 1-21 are subject to restriction and/or election requirement.

## Application Papers

- 9) ☐ The specification is objected to by the Examiner.
- 10) ☐ The drawing(s) filed on 19 September 2001 is/are: a) ☐ accepted or b) ☒ objected to by the Examiner.  
Applicant may not request that any objection to the drawing(s) be held in abeyance. See 37 CFR 1.85(a).
- 11) ☐ The proposed drawing correction filed on \_\_\_\_\_ is: a) ☐ approved b) ☐ disapproved by the Examiner.  
If approved, corrected drawings are required in reply to this Office action.
- 12) ☐ The oath or declaration is objected to by the Examiner.

## Priority under 35 U.S.C. §§ 119 and 120

- 13) ☒ Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f).  
a) ☒ All b) ☐ Some \* c) ☐ None of:  
1. ☒ Certified copies of the priority documents have been received.  
2. ☐ Certified copies of the priority documents have been received in Application No. \_\_\_\_\_.  
3. ☐ Copies of the certified copies of the priority documents have been received in this National Stage application from the International Bureau (PCT Rule 17.2(a)).  
\* See the attached detailed Office action for a list of the certified copies not received.
- 14) ☐ Acknowledgment is made of a claim for domestic priority under 35 U.S.C. § 119(e) (to a provisional application).  
a) ☐ The translation of the foreign language provisional application has been received.
- 15) ☐ Acknowledgment is made of a claim for domestic priority under 35 U.S.C. §§ 120 and/or 121.

## Attachment(s)

- 1) ☒ Notice of References Cited (PTO-892) 4) ☐ Interview Summary (PTO-413) Paper No(s) \_\_\_\_\_
- 2) ☐ Notice of Draftsperson's Patent Drawing Review (PTO-948) 5) ☐ Notice of Informal Patent Application (PTO-152)
- 3) ☒ Information Disclosure Statement(s) (PTO-1449) Paper No(s) 2 6) ☐ Other: \_\_\_\_\_

Attorney's Docket Number: 214019US2

Filing Date: 9/19/01

Continuing Data: none

Claimed Foreign Priority Date: 9/21/00 (JPX)

Applicant(s): Sakagami

Examiner: Howard Weiss

***Election/Restrictions***

1. The Applicant's election with out traverse of Group I, Claims 1 to 6, in Paper No. 5 is acknowledged. Claims 7 to 21 are withdrawn from consideration as being for a non-elected invention. The Applicant is requested to cancel the non-elected claims as part of a complete response to this office action. Cancellation of the non-elected claims would not preclude the later filing of a divisional application on the non-elected invention (please see 35 USC 120 and 121).

***Drawings***

2. Figures 14 to 21 should be designated by a legend such as --Prior Art-- because only that which is old is illustrated. See MPEP § 608.02(g). A proposed drawing correction or corrected drawings are required in reply to the Office action to avoid abandonment of the application. The objection to the drawings will not be held in abeyance.

***Specification***

3. The title of the invention is not descriptive. A new title is required that is clearly indicative of the invention to which the claims are directed.

***Claim Rejections - 35 USC § 112***

4. The following is a quotation of the second paragraph of 35 U.S.C. 112:

The specification shall conclude with one or more claims particularly pointing out and distinctly claiming the subject matter which the applicant regards as his invention.

5. Claims 1 to 6 are rejected under 35 U.S.C. 112, second paragraph, as being indefinite for failing to particularly point out and distinctly claim the subject matter which applicant regards as the invention.
6. Claim 1 is indefinite because it is an attempt to claim the invention by excluding what the Applicant did not invent (i.e. "said second gate insulating film does not include a charge storage layer" and said charge storage layer "does not exist in an element isolation region") rather than distinctly and particularly pointing out what they did invent. *In re Schechter*, 205 F.2d 185, 98 USPQ 144 (CCPA 1953). See MPEP § 2173.05(i).

#### ***Claim Rejections - 35 USC § 103***

7. The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:

(a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negated by the manner in which the invention was made.

8. Claim 1 is rejected under 35 U.S.C. 103(a) as being unpatentable over Ogura et al. (U.S. Patent No. 6,255,166) and Inoue (U.S. Patent No. 5,559,048).

Ogura et al. show most aspects of the instant invention (e.g. Figure 1) including:

- a semiconductor substrate **10**
- a first transistor used as a cell transistor including a first gate insulating film **132** and a first gate electrode **142**
- a second transistor used as a selection transistor including a second gate insulating film **131** and a second gate electrode **141**
- said first gate insulating film comprises a charge storage layer **132b** made of silicon nitride or tantalum oxide with top **132c** and bottom **132a** layers of silicon oxide and said second insulating layer not including a charge storage layer

Ogura et al. do not show the first and second transistor isolated by a trench. Inoue teach (e.g. Figure 9G) to isolate memory cells with trench isolations **108** to prevent leakage current flow (Column 9 Lines 36 to 52). It would have been obvious to a person of ordinary skill in the art at the time of invention to isolate memory cells with trench isolations as taught by Inoue in the device of Ogura et al. to prevent leakage current flow.

9. Claims 2, 3 and 5 are rejected under 35 U.S.C. 103(a) as being unpatentable over Ogura et al. and Inoue, as applied to Claim 1 above, and further in view of Reisinger.

Ogura et al. and Inoue show most aspects of the instant invention (Paragraph 8) except for the thickness ranges and that the thickness of the bottom oxide layer is smaller than the top oxide layer. Reisinger teaches (e.g. Figure 1 and Column 5 Lines 45 to 56) to form a triple layer gate insulating layer **5** with the thicknesses within the claimed ranges and with the thickness of the bottom oxide layer **51** is smaller than the top oxide layer **53** to increase storage density and data retention (Column 2 Lines 7 to 12). It would have been obvious to a person of ordinary skill in the art at the time of invention to form a triple layer gate insulating layer with the thicknesses within the claimed ranges and with the thickness of the bottom oxide layer is smaller than the top oxide layer as taught by Reisinger in the device of Ogura et al. and Inoue to increase storage density and data retention.

10. Claim 4 is rejected under 35 U.S.C. 103(a) as being unpatentable over Ogura et al., Inoue and Reisinger, as applied to Claim 1 above, and further in view of Agarwal et al. (U.S. Patent No. 6,201,276)

Ogura et al., Inoue and Reisinger disclose the claimed invention (Paragraph 9) except that the charge storage layer comprising either a silicon nitride or a tantalum oxide film instead of either a strontium titanate or a barium strontium titanate film. Agarwal et al. teach (Column 4 Lines 33 to 36) that either a strontium titanate or a

barium strontium titanate film are equivalent structure known in the art. Therefore, because these charge storage films were art-recognized equivalents at the time the invention was made, one of ordinary skill in the art would have found it obvious to substitute either silicon nitride or tantalum oxide for strontium titanate or barium strontium titanate.

11. Claim 6 is rejected under 35 U.S.C. 103(a) as being unpatentable over Ogura et al. and Inoue, as applied to Claim 1 above, and further in view of Fang (U.S. Patent No. 6,023,085).

Ogura et al. and Inoue show most aspects of the instant invention (Paragraph 8) except for the first peripheral transistor consisting of a third gate insulating film and a third gate electrode and a second peripheral transistor consisting of a fourth gate insulating film and a fourth gate electrode and the thicknesses of the third and fourth gate insulating film being different. Fang teaches (e.g. Figure 9H) to have peripheral transistors **332, 342** with gate electrodes **338** and gate insulting films **337,336** of different thicknesses to improve performance and reliability while simplifying manufacture (Column 2 Lines 51 to 54). It would have been obvious to a person of ordinary skill in the art at the time of invention to have peripheral transistors with gate electrodes and gate insulting films of different thicknesses as taught by Fang in the device of Ogura et al. and Inoue to improve performance and reliability while simplifying manufacture.

### ***Conclusion***

12. Papers related to this application may be submitted directly to Art Unit 2814 by facsimile transmission. Papers should be faxed to Art Unit 2814 via the Art Unit 2814 Fax Center located in Crystal Plaza 4, room 3C23. The faxing of such papers must conform with the notice published in the Official Gazette, 1096 OG 30 (15 November 1989). The Art Unit 2814 Fax Center number is **(703) 308-7722** or **-7724**. The Art Unit 2814 Fax Center is to be used only for papers related to Art Unit 2814

applications. The official TC2800 Before-Final, **(703) 872-9318**, and After-Final, **(703)-872-9319** Fax numbers will provide the fax sender with an auto-reply fax verifying receipt of their fax by the USPTO.

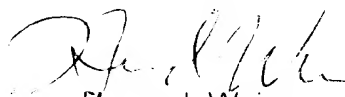
13. Any inquiry concerning this communication or earlier communications from the examiner should be directed to Howard Weiss at **(703) 308-4840** and between the hours of 8:00 AM to 4:00 PM (Eastern Standard Time) Monday through Friday or by e-mail via **Howard.Weiss@uspto.gov**.

Any inquiry of a general nature or relating to the status of this application should be directed to the Group 2800 Receptionist at **(703) 308-0956**.

14. The following list is the Examiner's field of search for the present Office Action:

Field of Search	Date
U.S. Class / Subclass(es): 257/ 324,326	5/31/02
Other Documentation: PLUS Analysis Report	5/24/02
Electronic Database(s): EAST, IEL	5/24/02

HW/hw  
3 June 2002

  
Howard Weiss  
Examiner  
Art Unit 2814